# Multimodal Modeling of DPC-STEM To Improve Electrostatic Sensitivity





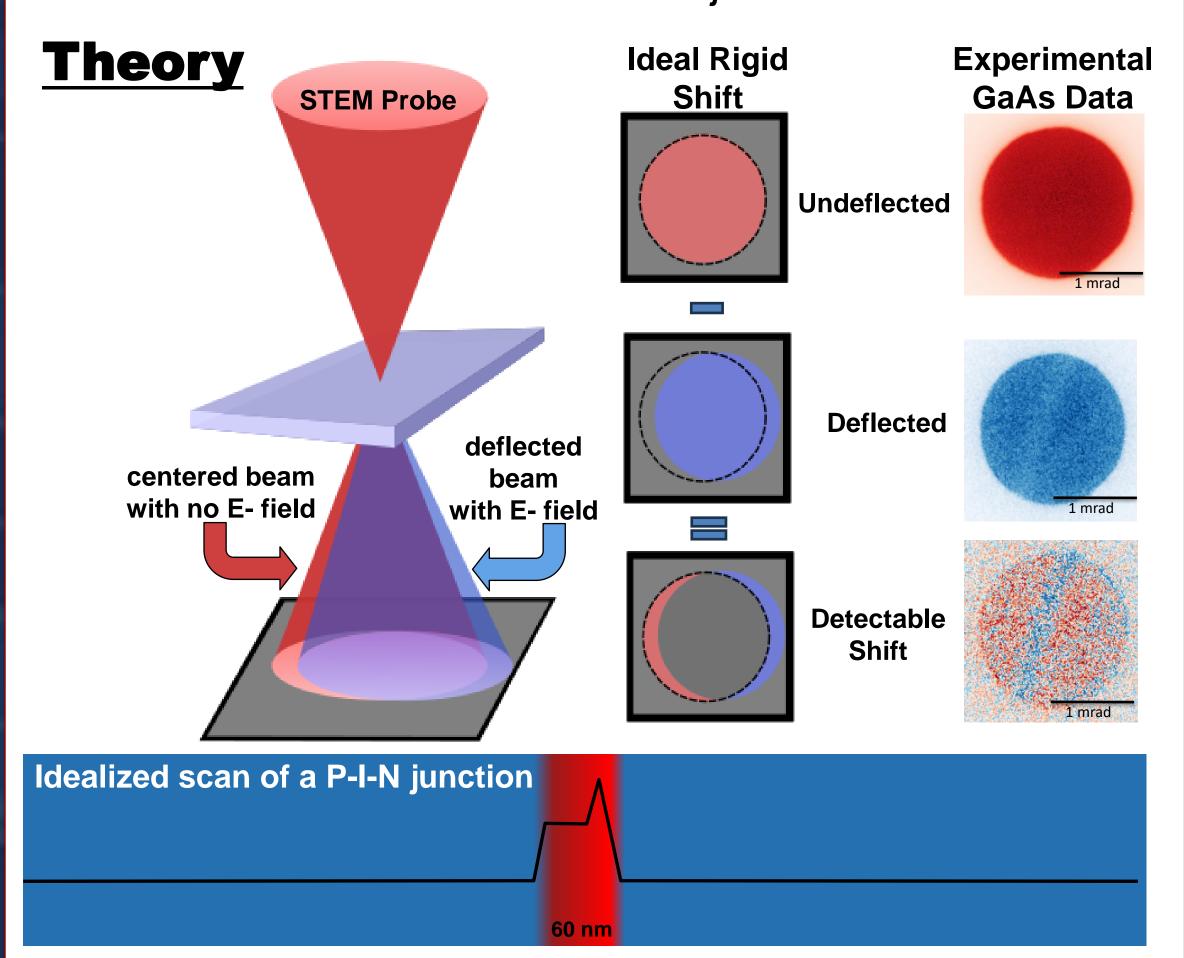
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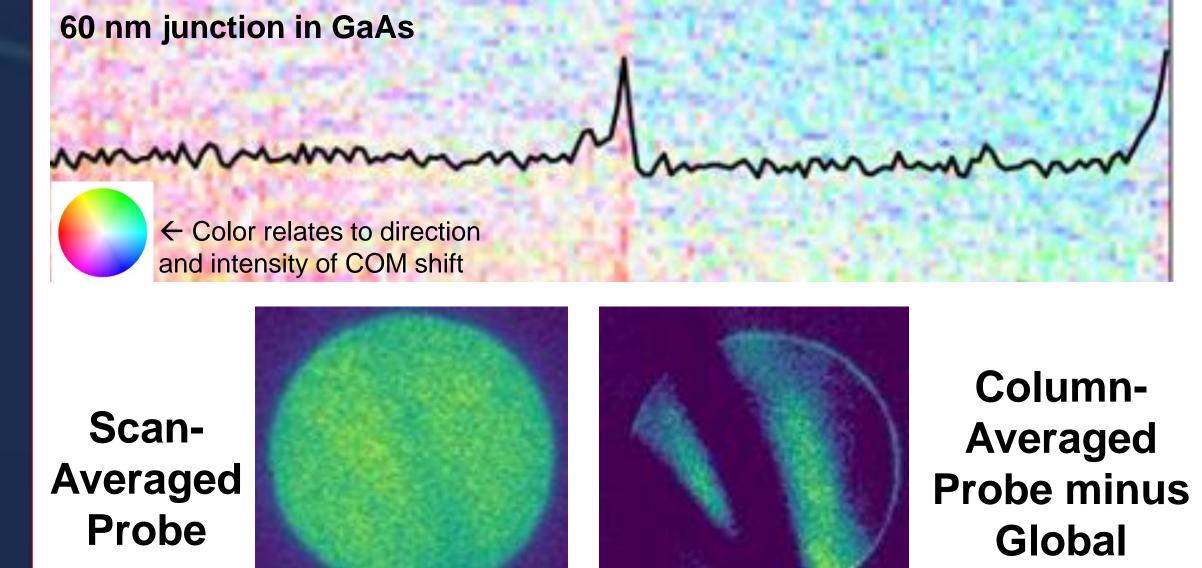
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#### **BACKGROUND**

Differential Phase Contrast Scanning Transmission Electron Microscopy (DPC-STEM) is a method by which electrostatic forces can be spatially resolved around atomic-scale defects and junctions.

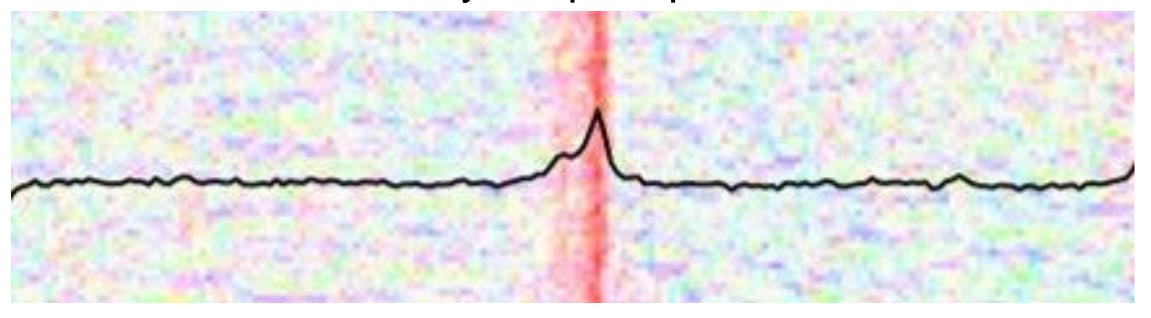


#### Reality



Inherent diffraction events like Kikuchi and HOLZ lines affect the probe, altering the **Center-of-Mass** (COM) calculation and obscuring the electric field data.

This can, with difficulty, be post-processed out ...



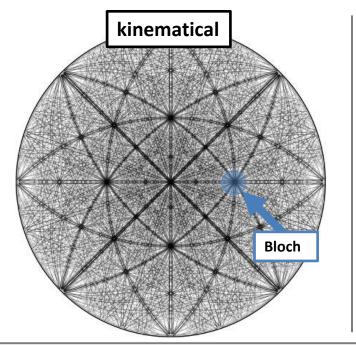
Motivation: What if instead, the diffraction events could be modeled a-priori and thus avoided altogether?

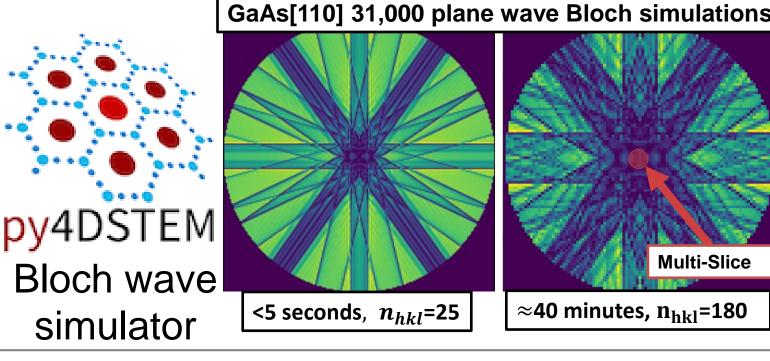
#### GOAL

Can we quickly predict which specimen orientations will minimize diffraction interference for DPC-STEM?

### Modeling options: Kinematical, Bloch Wave, and Multi-Slice GaAs[110] 31,000 plane wave Bloch simulations Between 10 and 100,000 kikuchipy

≈ Million simulations/second No interactions between diffracted beams. Ideal for building "road map"

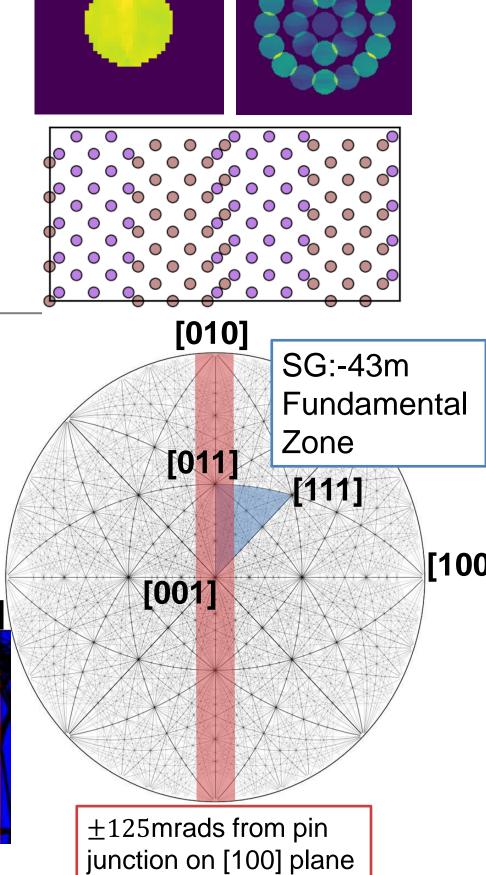




simulations/second. Assumes dynamical diffraction in a homogenous material, Scales  $\approx (n^2) \log(n)$  with the number of [hkl] reflections considered.

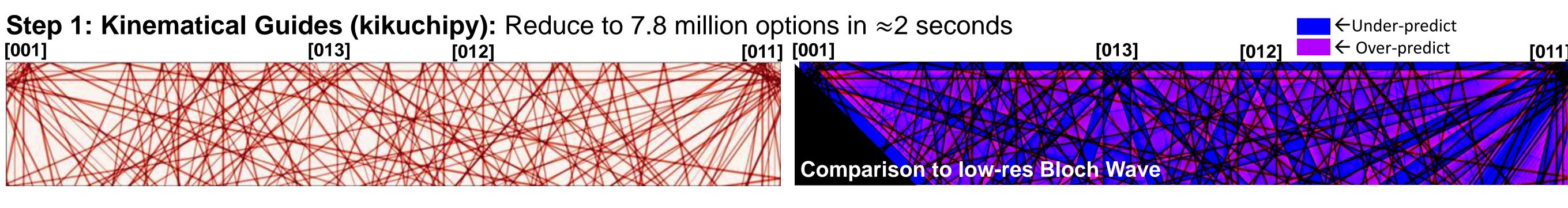


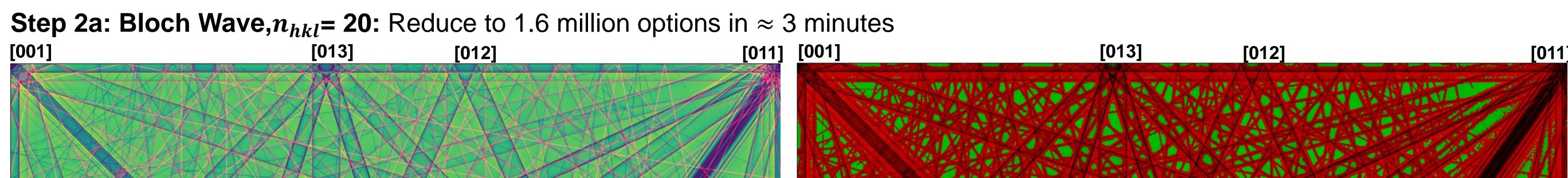
**Between 1-1000** simulations /hour. The most accurate and most customizable. Can model the whole junction instead of only an ideal crystal.

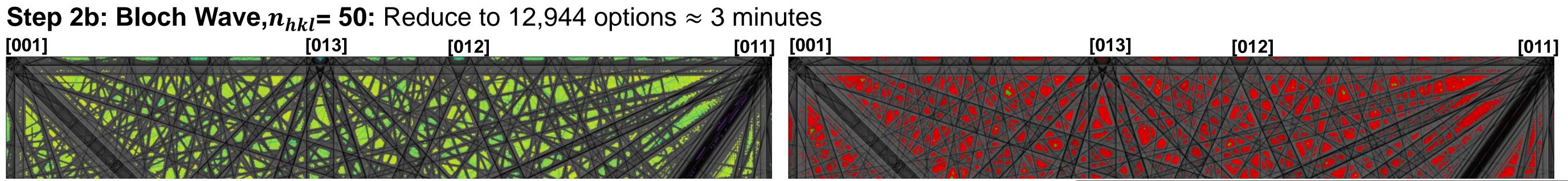


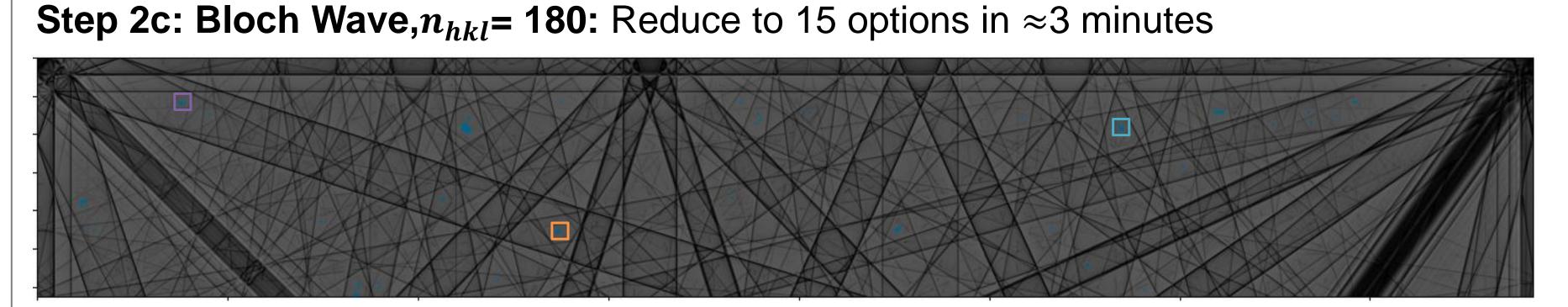
### Sequential Search models of increasing fidelity

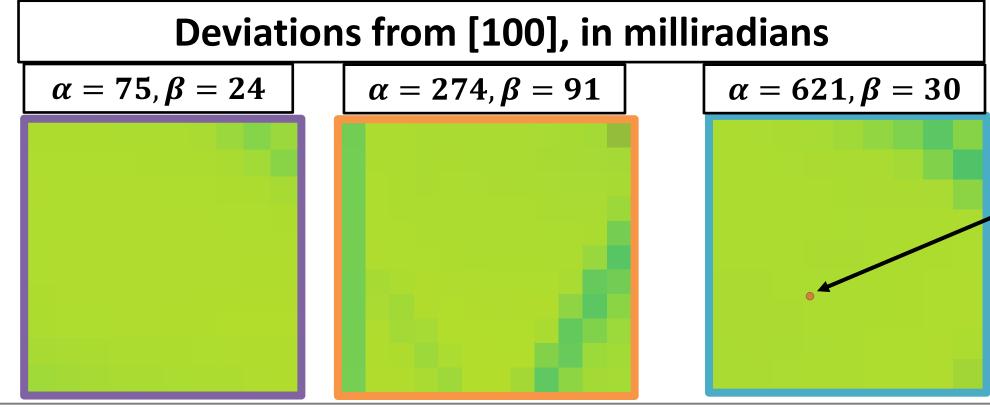
- At a 100  $\mu$ -rad mesh,  $\approx$ **1 billion** unique probes. Symmetry and experimental constraints reduces this to  $\approx$ **9.8 million.**
- This is still too many to fully model, but many options can be eliminated by fast, lower-fidelity checks.











Relative size of a l milliradian diameter probe

#### **Next Steps**

- Computational verification via Multi-Slice
  - Ab-TEM is capable of capturing crucial additional physics (lattice strain at the junction, thermal effects, lens aberrations, etc), and is an ideal final verification step.
- **Experimental verification**
- Scheduled for mid-August 2025
- Additional modeling for a radially processed probe
- Akin to searching a "donut" of minimal change. Procession is an additional technique for reducing unwanted background signal.
- Allow real time feedback from microscope to the model, aka "Digital Twin"



Link to poster, references, and more on GitHub!